



Micron Docket No.: 00-0470
Docket No.: M4065.0466/P466
(PATENT)

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Patent Application of:
Neal Rueger

Application No.: 09/938,644

Group Art Unit: N/A

Filed: August 27, 2001

Examiner: Not Yet Assigned

For: A METHOD AND APPARATUS FOR
MICROMACHINING USING A
MAGNETIC FIELD AND PLASMA
ETCHING THEREBY

**POWER OF ATTORNEY BY ASSIGNEE AND
CERTIFICATE BY ASSIGNEE UNDER 37 CFR § 3.73(B)**

Assistant Commissioner for Patents
Washington, DC 20231

Dear Sir:

Micron Technology, Inc., Assignee of the entire right, title and interest in the above-identified application by virtue of the Assignment attached hereto (which is also being submitted concurrently for recordation), hereby appoints the attorneys and agents of the firm of Dickstein Shapiro Morin & Oshinsky LLP located at 2101 L Street NW, Washington, DC 20037-1526, listed as follows:

Gary M. Hoffman	26,411	Laurence E. Fisher	37,131	Gianni Minutoli	41,198
Thomas J. D'Amico	28,371	John C. Luce	34,378	Michael Bergman	42,318
Donald A. Gregory	28,954	William E. Powell, III	39,803	Mark E. Strickland	45,138
James W. Brady, Jr.	32,115	Patrick T. Skacel	47,948	Salvatore P. Tamburo	45,153
Jon D. Grossman	32,699	Gary L. Veron	39,057	Peter Veytsman	45,920
Mark J. Thronson	33,082	Mialeeka C. Williams-Bibbs	48,037	Christopher S. Chow	46,493
Eric Oliver	35,307	Jeremy A. Cubert	40,399	Ryan H. Flax	48,141

and also, listed as follows:

Application No.: Not Assigned

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Michael Lynch 30,871 David Paul
Kevin Martin 37,882 Walter Fields

34,692 Charles Brantley 38,086
37,130

attorneys of Micron Technology, Inc. as its attorneys with full power of substitution to prosecute this application and to transact all business in the Patent and Trademark Office in connection therewith.


The Assignee certifies that the above-identified assignment has been reviewed and to the best of the Assignee's knowledge and belief, title is in the assignee.

Please direct all correspondence regarding this application to the following:

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Respectfully submitted,

MICRON TECHNOLOGY, INC.



Michael L. Lynch
Chief Patent Counsel
Registration No. 30,871

Dated: 4-8-01

ASSIGNMENT AND AGREEMENT

For value received, I, Neal Rueger, hereby sell, assign and transfer to Micron Technology, Inc., a corporation of the State of Delaware, having an office at 8000 S. Federal Way, Boise, Idaho 83706-9632, U.S.A., and its successors, assigns and legal representatives, the entire right, title and interest, for the United States of America, in and to certain inventions related to an invention entitled A METHOD AND APPARATUS FOR MICROMACHING USING A MAGNETIC FIELD AND PLASMA ETCHING THEREBY, described in an application for Letters Patent of the United States, executed by me of even date herewith, and all the rights and privileges in said application and under any and all Letters Patent that may be granted in the United States for said inventions; and I also concurrently hereby sell, assign and transfer to Micron Technology, Inc. the entire right, title and interest in and to said inventions for all countries foreign to the United States, including all rights of priority arising from the application aforesaid, and all the rights and privileges under any and all forms of protection, including Letters Patent, that may be granted in said countries foreign to the United States for said inventions.

I authorize Micron Technology, Inc. to make application for such protection in its own name and maintain such protection in any and all countries foreign to the United States, and to invoke and claim for any application for patent or other form of protection for said inventions, without further authorization from me, any and all benefits, including the right of priority provided by any and all treaties, conventions, or agreements.

I hereby consent that a copy of this assignment shall be deemed a full legal and formal equivalent of any document which may be required in any country in proof of the right of Micron Technology, Inc. to apply for patent or other form of protection for said inventions and to claim the aforesaid benefit of the right of priority.

I request that any and all patents for said inventions be issued to Micron Technology, Inc. in the United States and in all countries foreign to the United States, or to such nominees as Micron Technology, Inc. may designate.



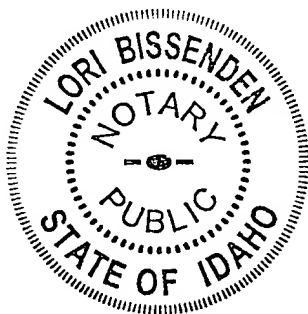
I agree that, when requested, I shall, without charge to Micron Technology, Inc. but at its expense, sign all papers, and do all acts which may be necessary, desirable or convenient in connection with said applications, patents, or other forms of protection.

Neal R. Rueger
Neal Rueger

Date: August 20, 2001

United States of America)
State of Idaho) ss.:
County of Ada)

On this 20th day of August, 2001, before me personally came Neal Rueger, to me known to be the individual described in and who executed the foregoing instrument, and acknowledged execution of the same.



Lori Bissenden
Notary Public